



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 14, 2024

IGI Report Number
Description
Shape and Cutting Style
Measurements

LG650480534
LABORATORY GROWN DIAMOND
CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
8.23 X 5.55 X 3.76 MM

GRADING RESULTS

Carat Weight
Color Grade
Clarity Grade

1.51 CARAT
D
VS 1

ADDITIONAL GRADING INFORMATION

Polish
Symmetry
Fluorescence

EXCELLENT
EXCELLENT
NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI LG650480534

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PROPORTIONS

Medium To Slightly Thick

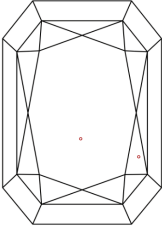
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49%

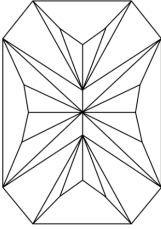
65%

67.7%

Pointed

CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

IGI Logo

QR Code

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September 14, 2024

IGI Report No
CUT CORNERED RECT. MODIFIED BRILLIANT

8.23 X 5.55 X 3.76 MM
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Medium to Slightly Thick
Culet
Polish
Symmetry
Fluorescence
Inscription(s)

1.51 CARAT
D
VS 1
67.7%
65%
Medium to Slightly Thick
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG650480534

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